

# Characterization and investigation of Fe:STO thin films prepared by pulsed laser deposition

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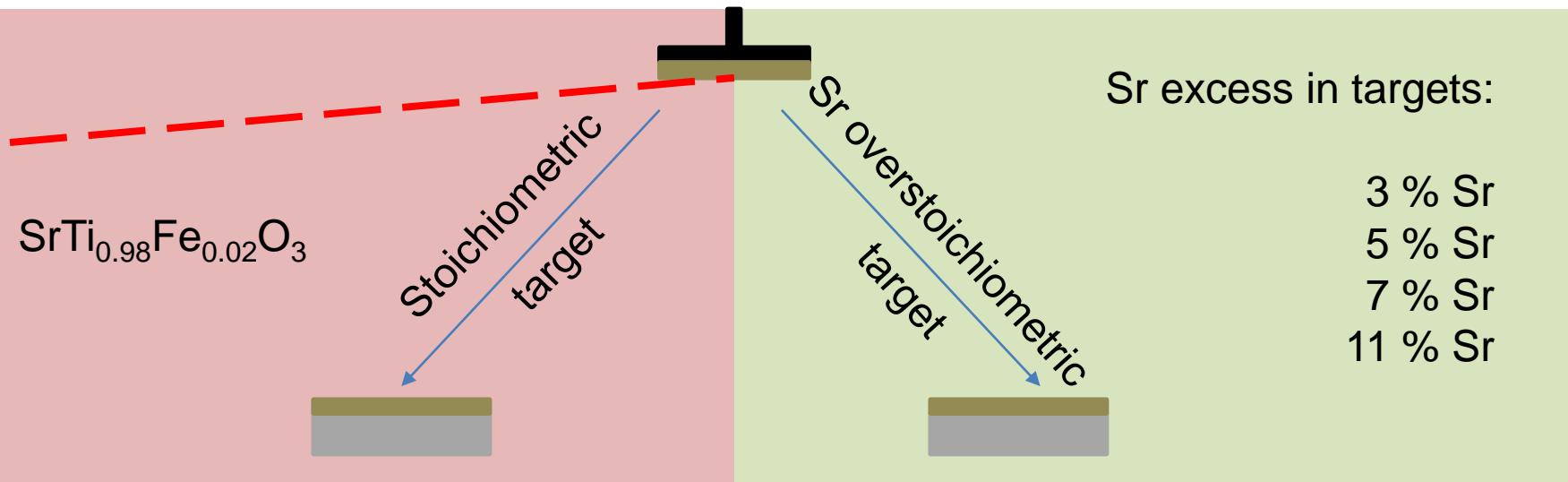
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# Introduction

- Bulk  $\text{SrTiO}_3$  well researched, defect model well known
- Conductivity of STO can be tailored by doping
- Effect of cation nonstoichiometry on (electrical) properties not so well researched
- Aim: linking stoichiometry, structure and properties of Fe: $\text{SrTiO}_3$

# Sample preparation via PLD



Deposition parameters

Standard: 400 mJ set, 650 °C,  
0.15 mbar  $\text{O}_2$ ; 5 Hz

Variation of laser fluence and  
repetition rate for stoichiometric  
targets

Substrates:

Electrical measurements: Nb:STO

XRD (reciprocal space map): STO

XRD (thin film gracing incidence): MgO

ICP-OES: MgO

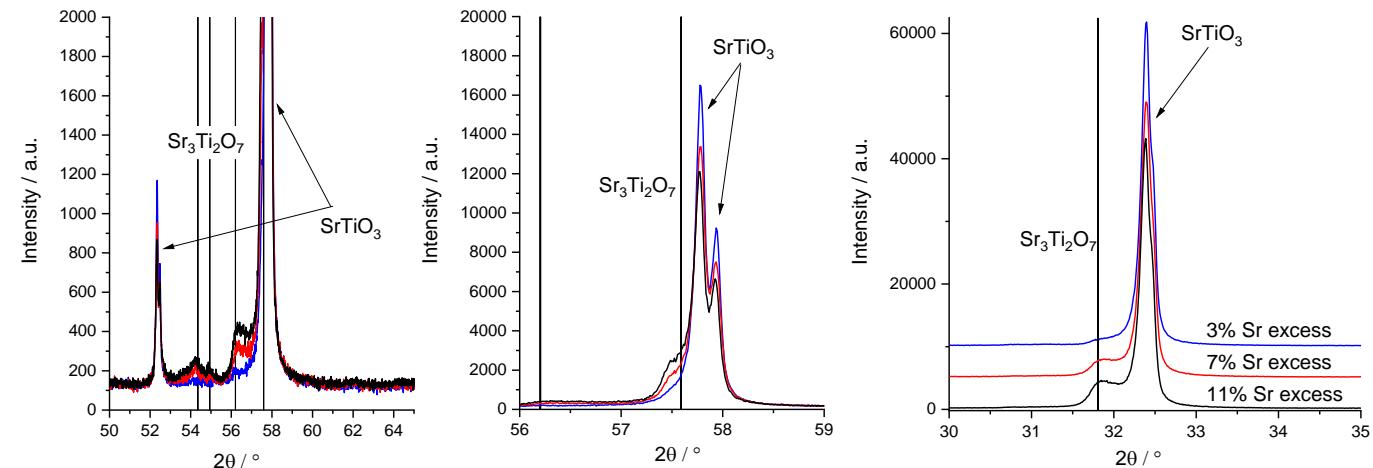
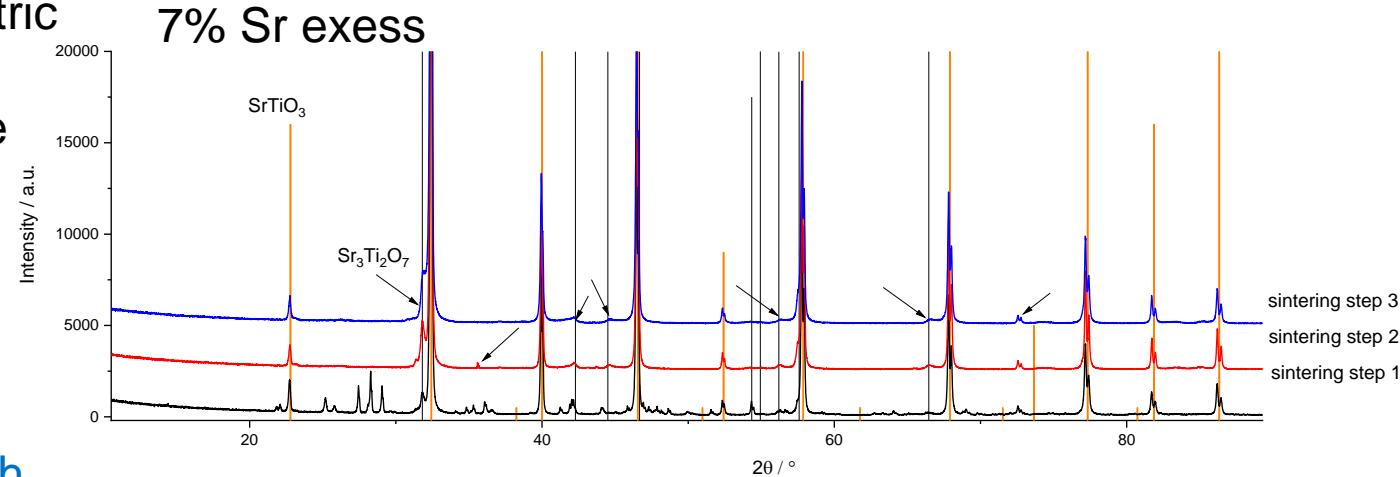
# X-ray diffraction of targets

With Sr overstoichiometry

Overstoichiometric targets:

Solid state route pressing, then  
1) 1000 °C, 2 h  
**2) 1200 °C, 4 h**  
remilling and pressing  
**3) 1400 °C, 4.5 h**

Sr-rich phases are present even after three sintering steps.



# X-ray diffraction of targets

With Sr  
overstoichiometry

Overstoichiometric

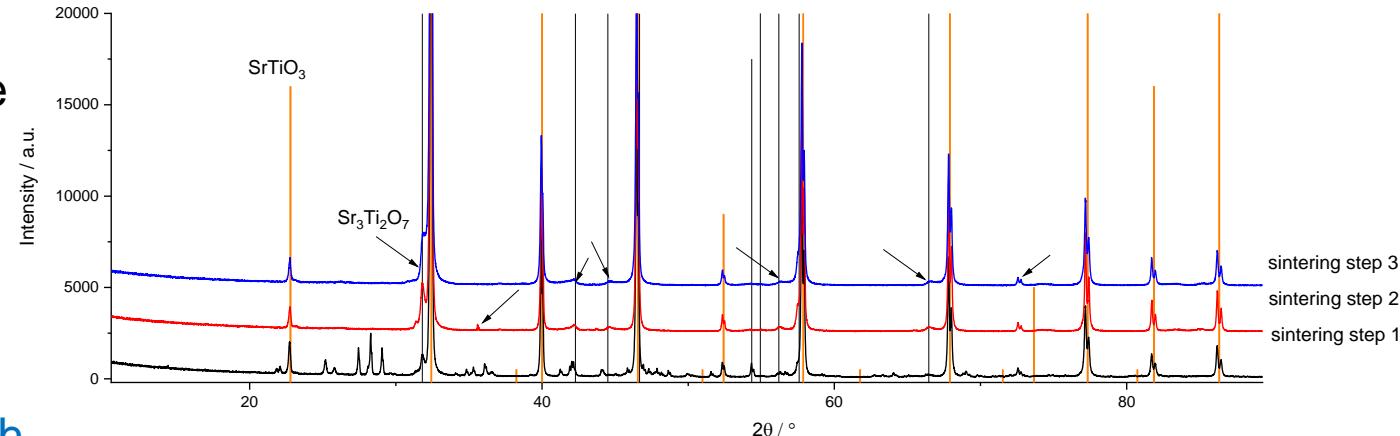
targets:

Solid state route  
pressing, then

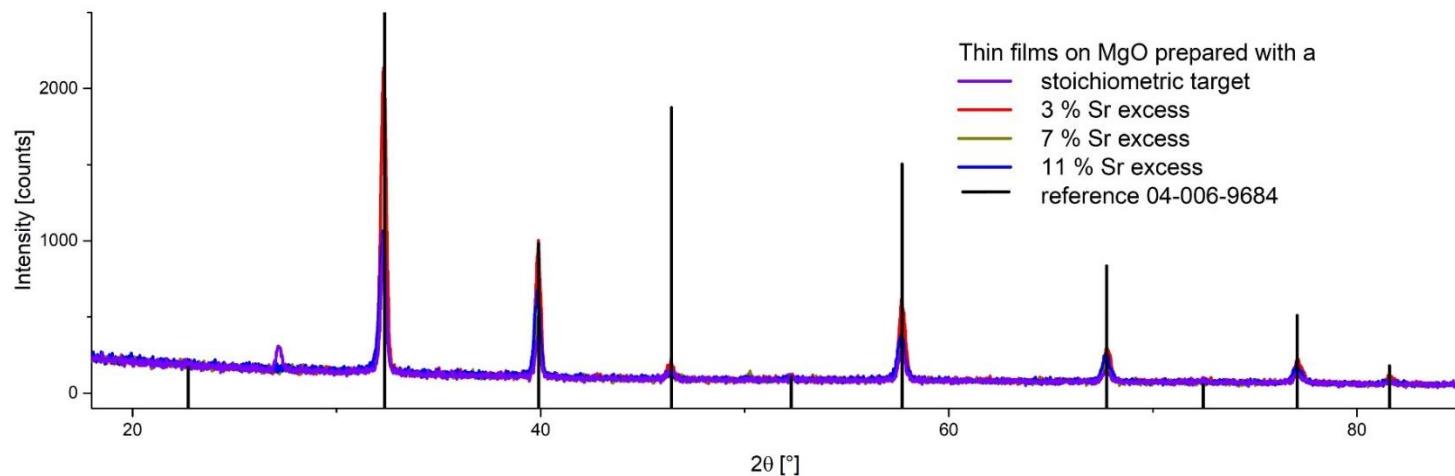
1) 1000 °C, 2 h  
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remilling and  
pressing

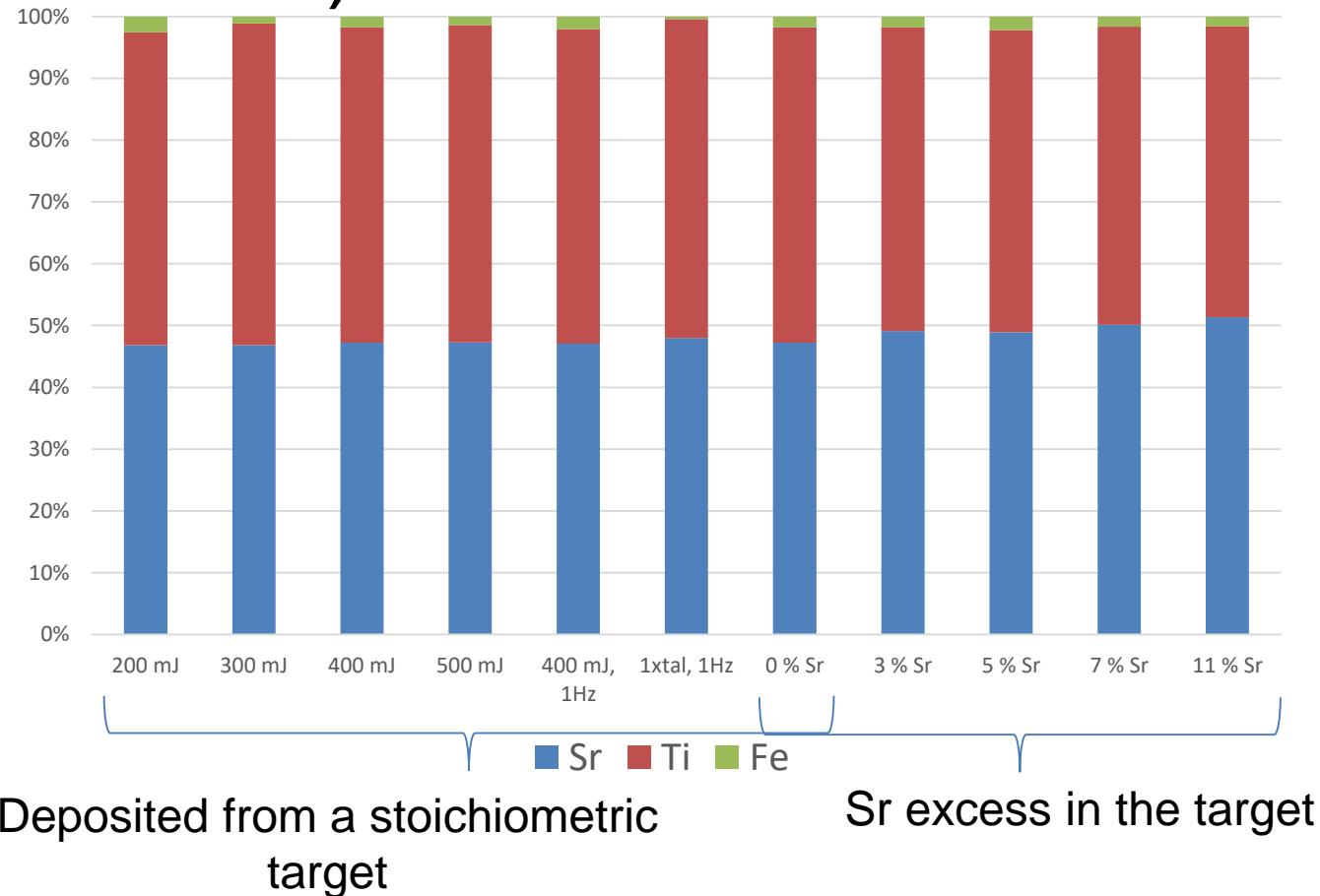
3) 1400 °C, 4.5 h



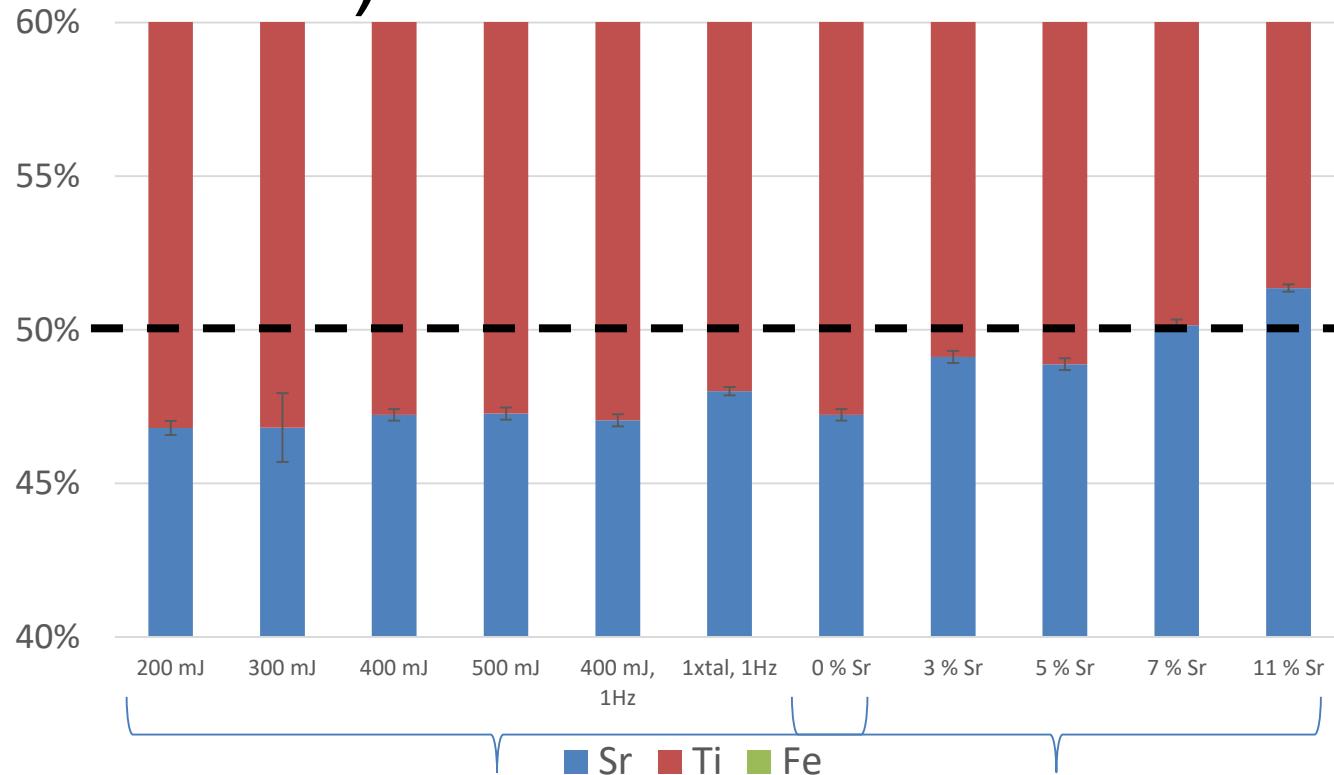
Thin films are  
phase pure



# Chemical analysis of thin films (ICP-OES)



# Chemical analysis of thin films (ICP-OES)

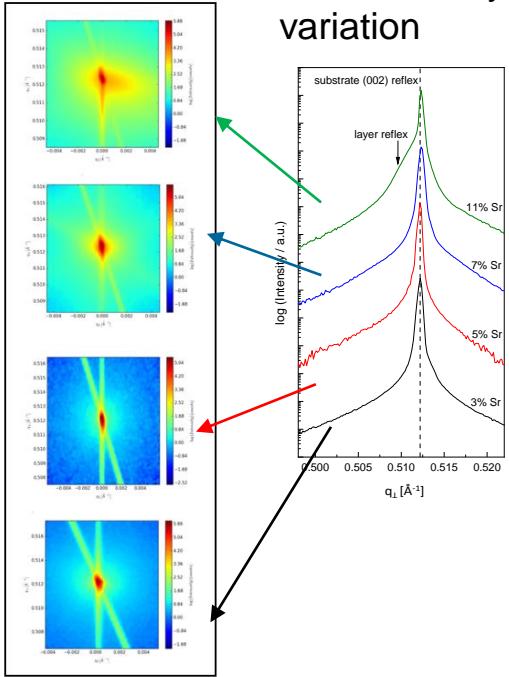


Deposited from a stoichiometric target

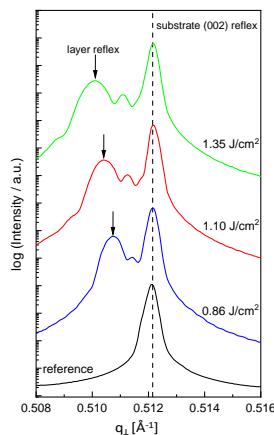
Sr excess in the target

# X-ray diffraction of thin films

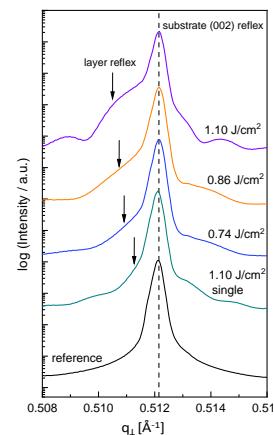
Stoichiometry variation



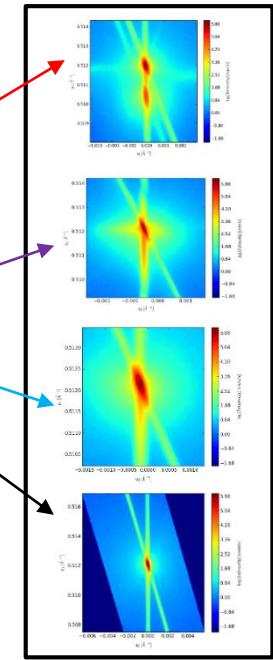
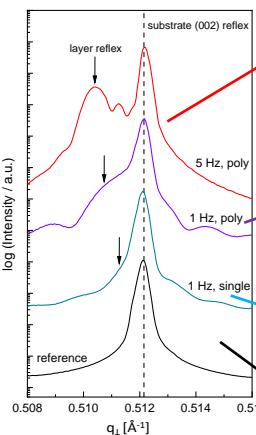
Fluence variation (5 Hz)



Fluence variation (1 Hz)



Frequency variation



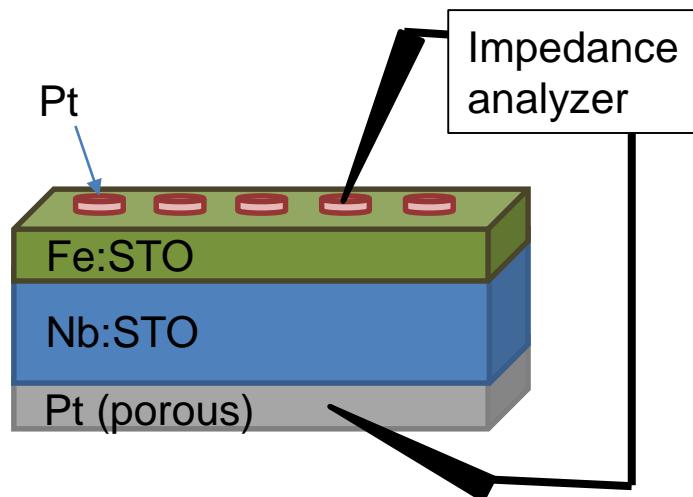
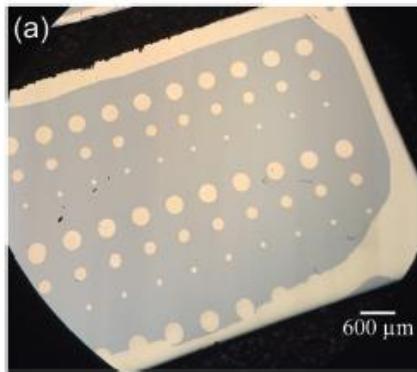
Thin films deposited on STO substrates (=reference)

Deposited from Sr overstoichiometric targets

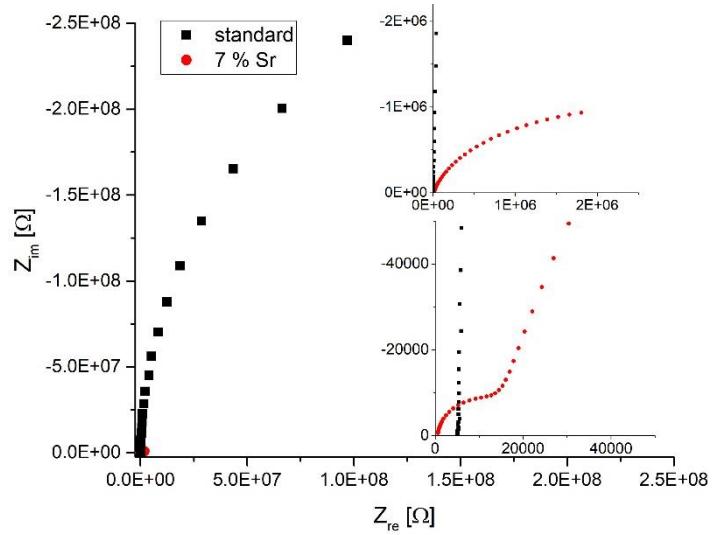
Deposited from stoichiometric targets

# Conductivity measurements

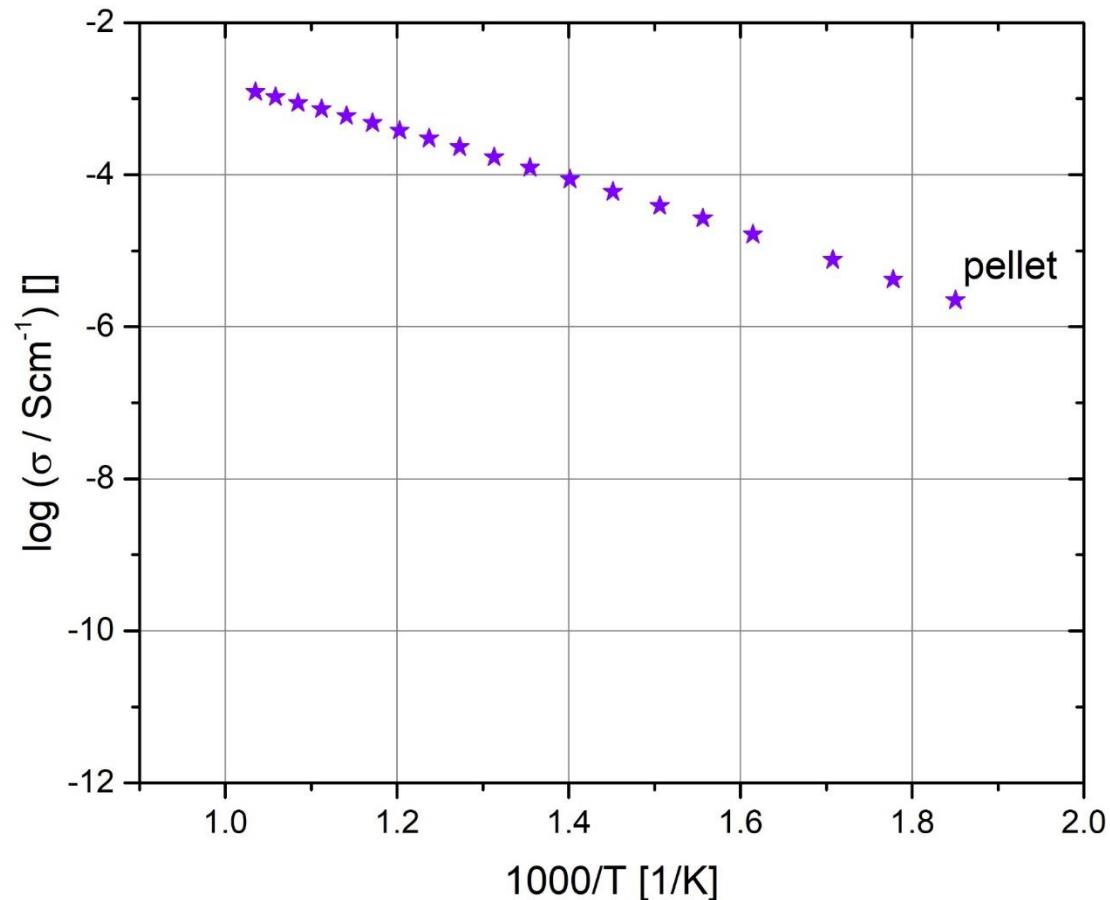
By means of Electrochemical Impedance Spectroscopy



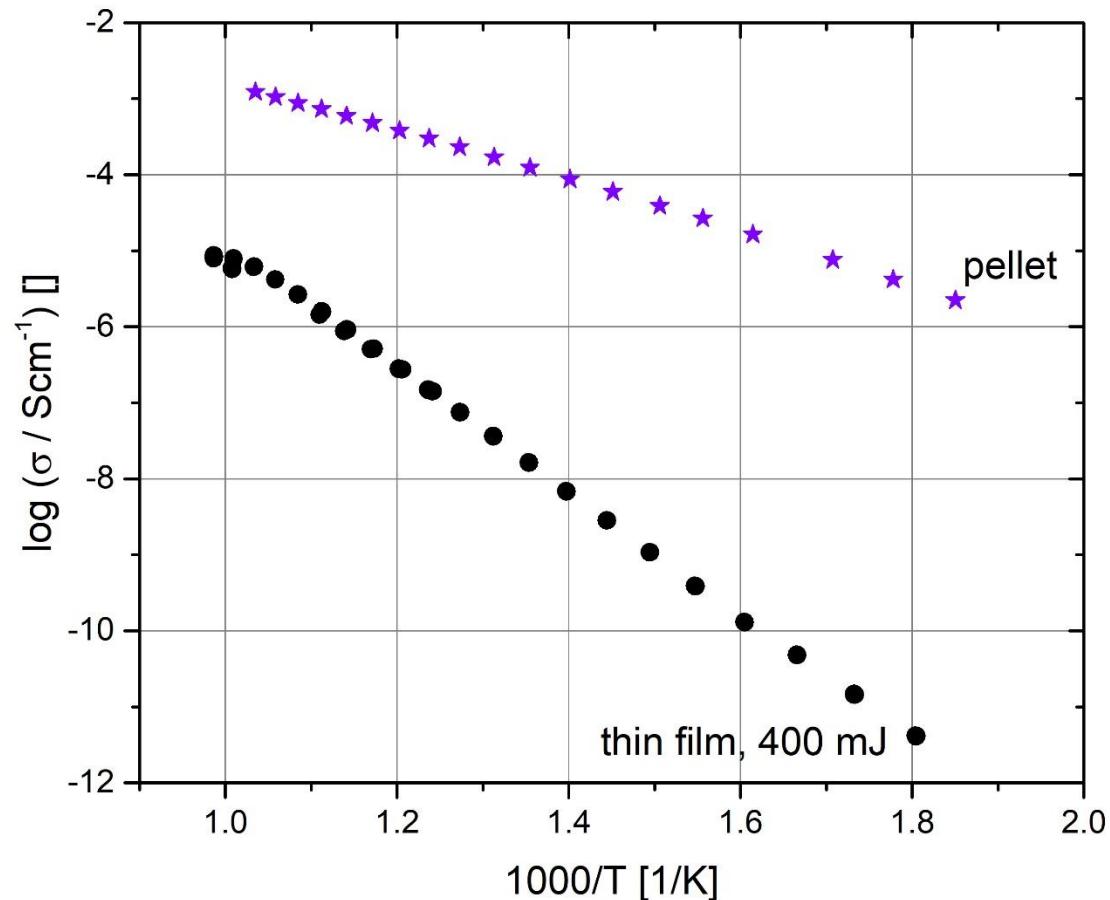
## Nyquist Plot 300 °C



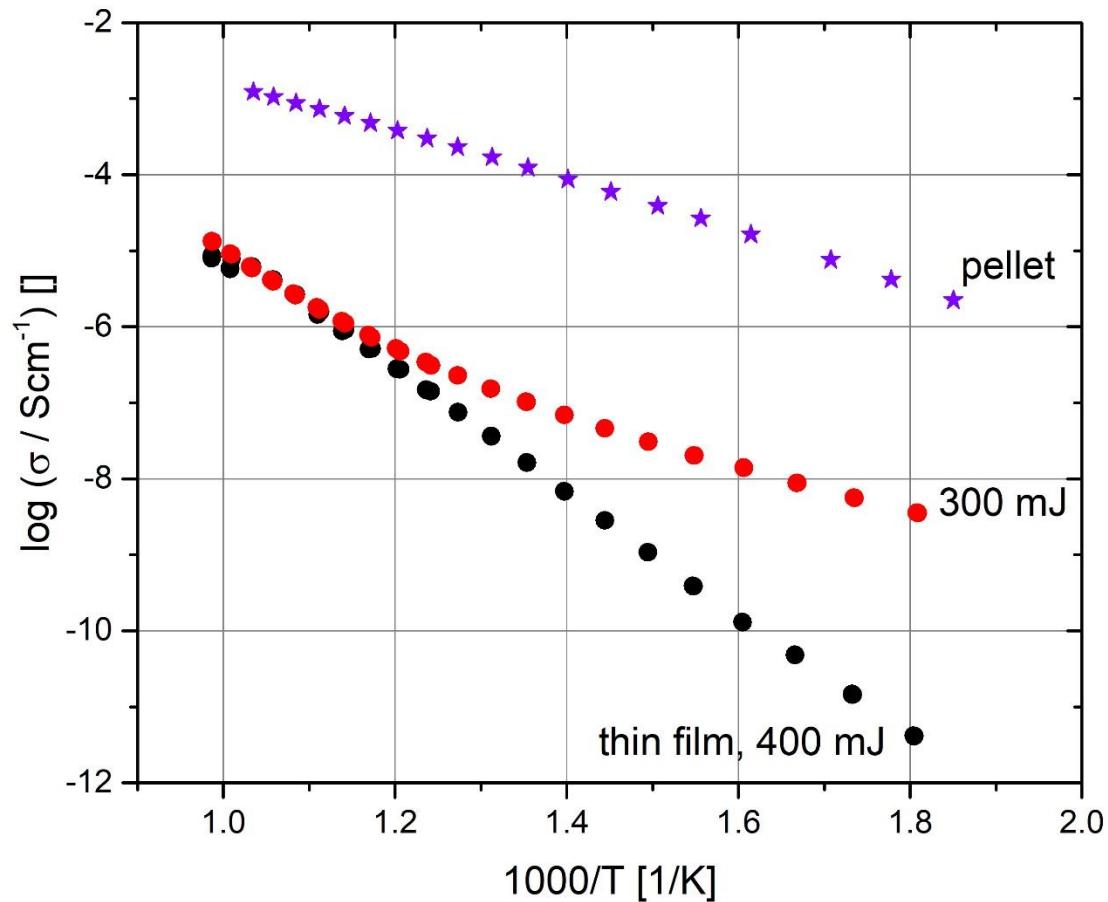
# Conductivity



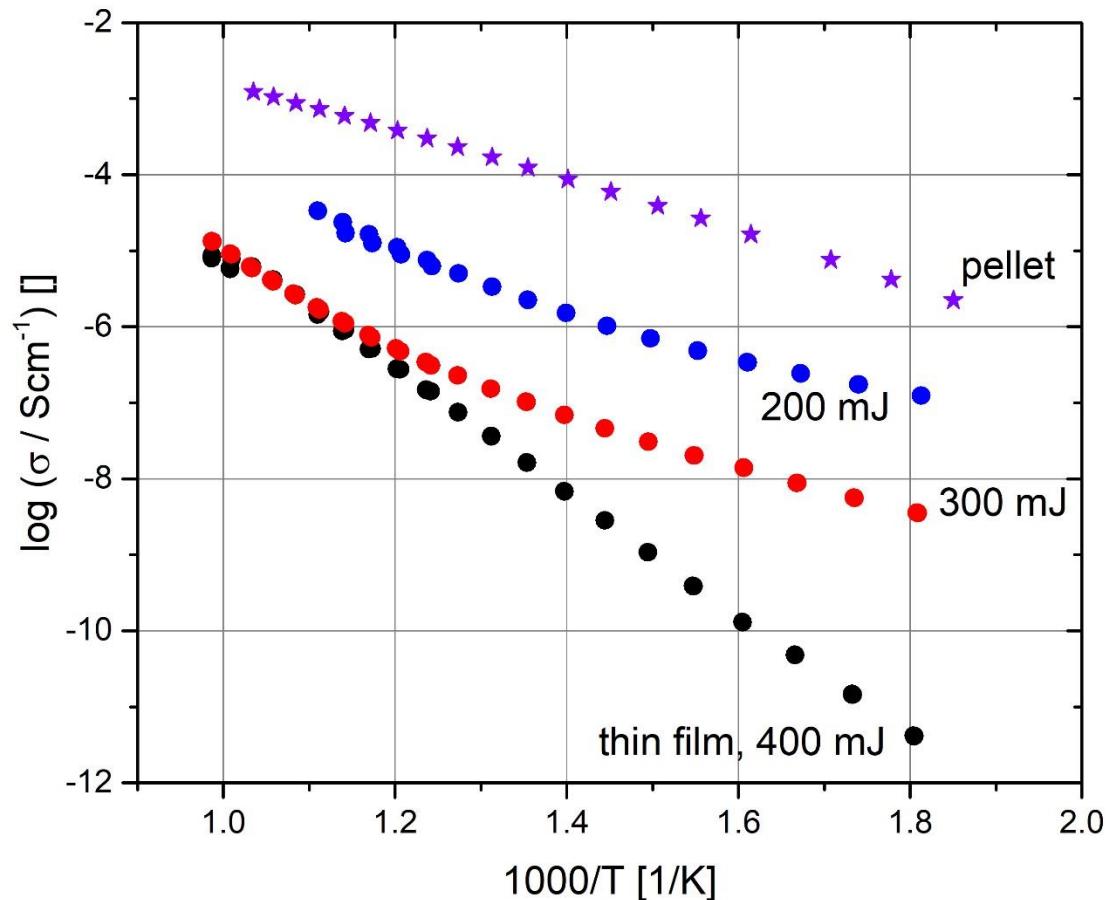
# Conductivity



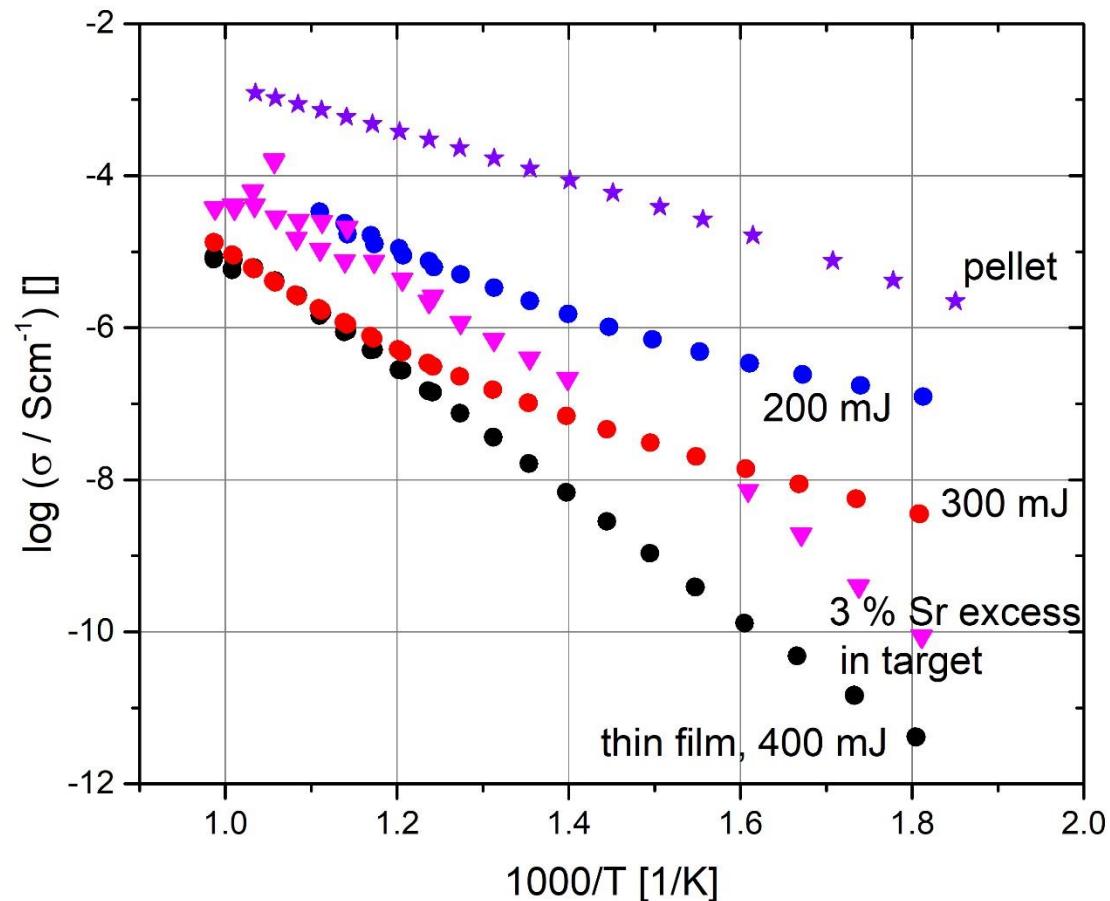
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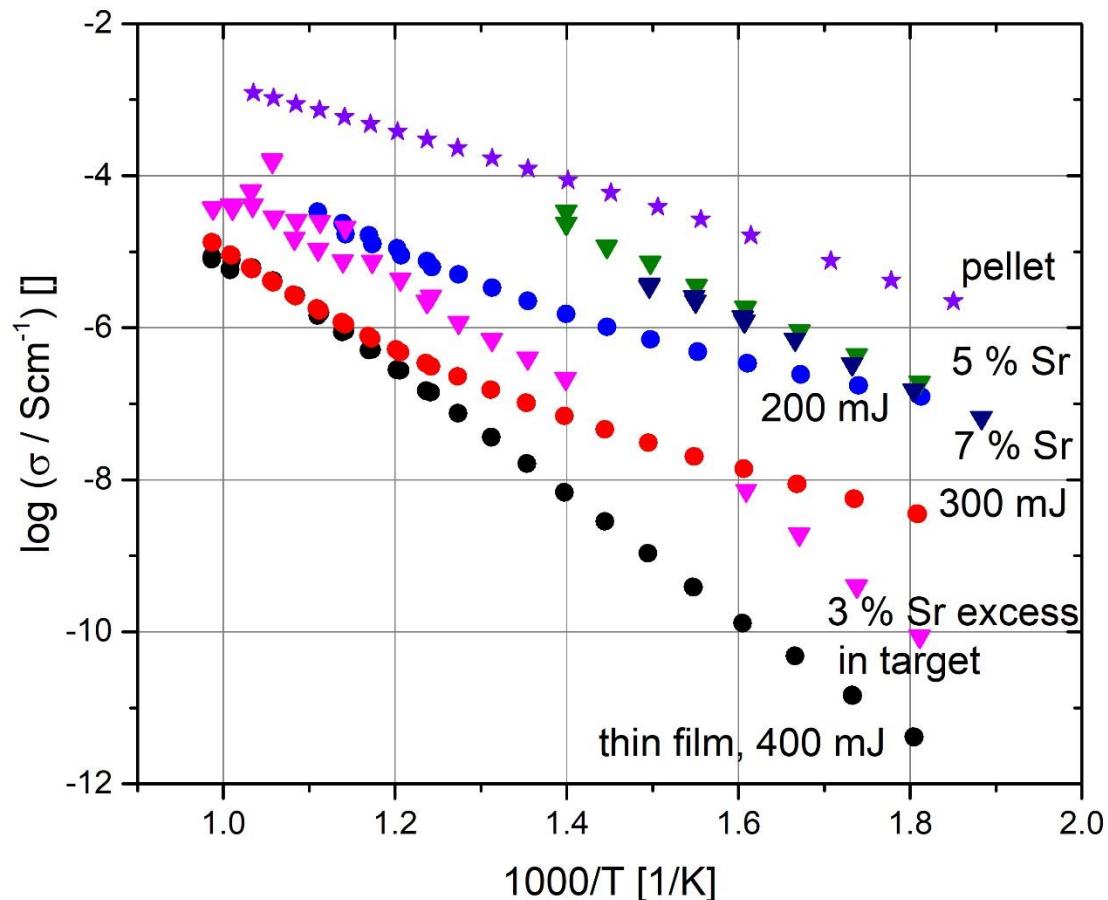
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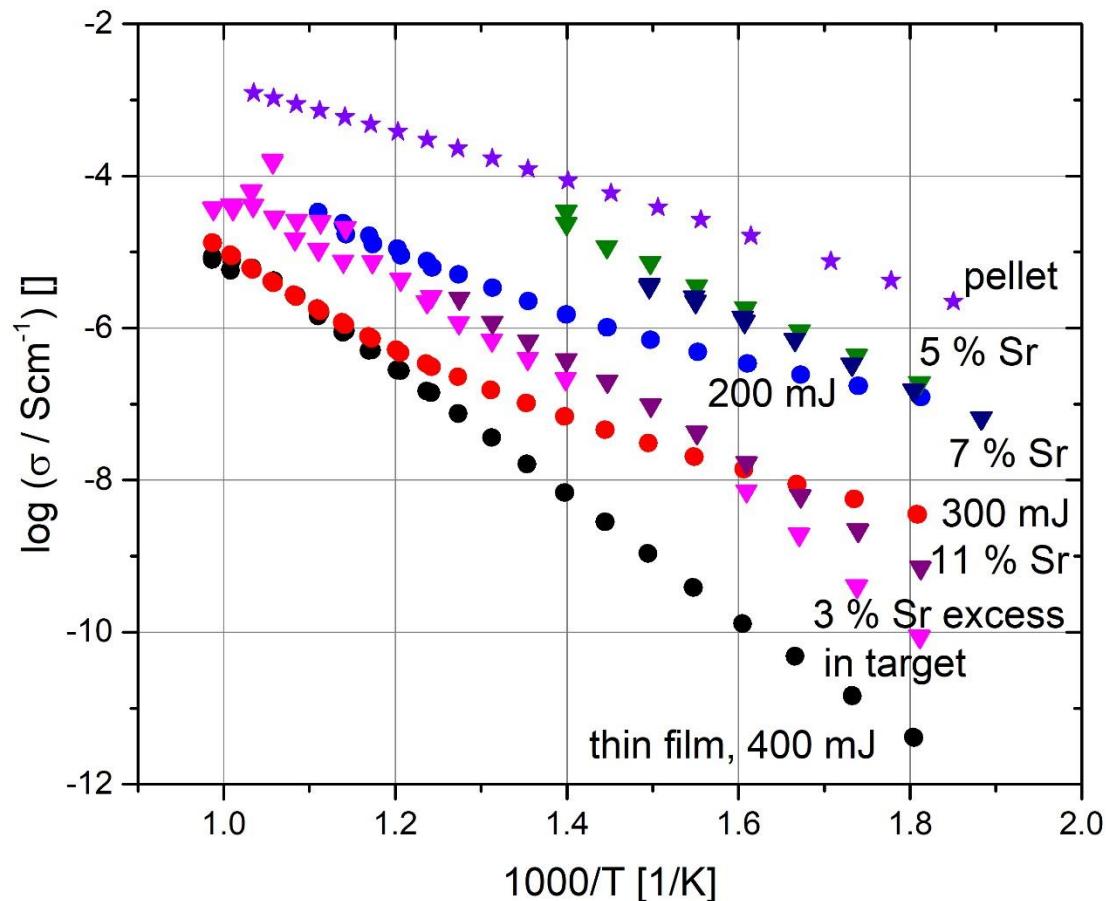
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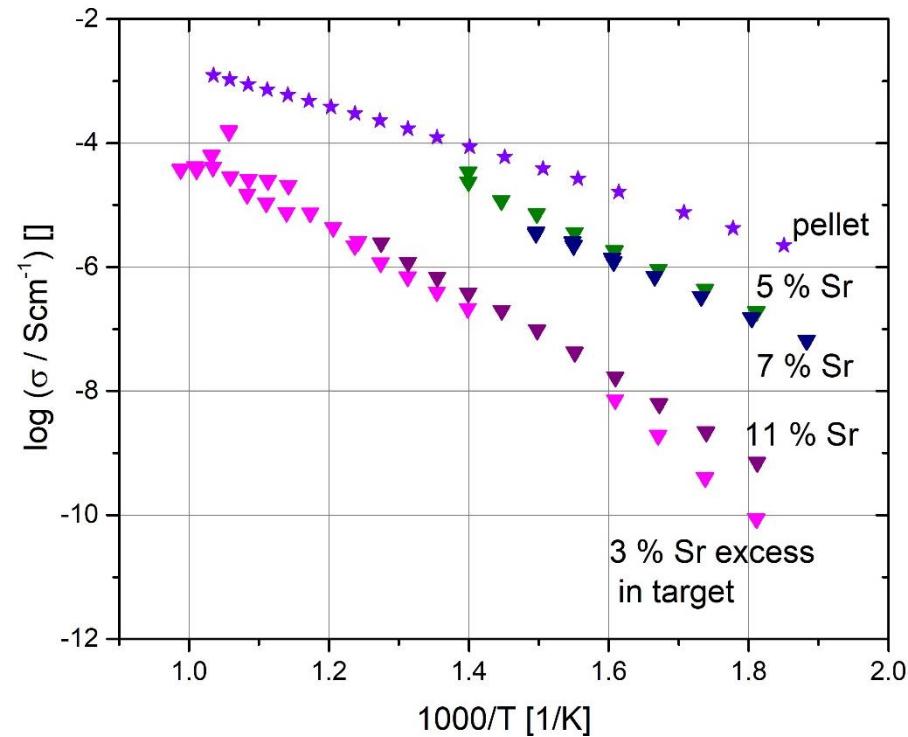
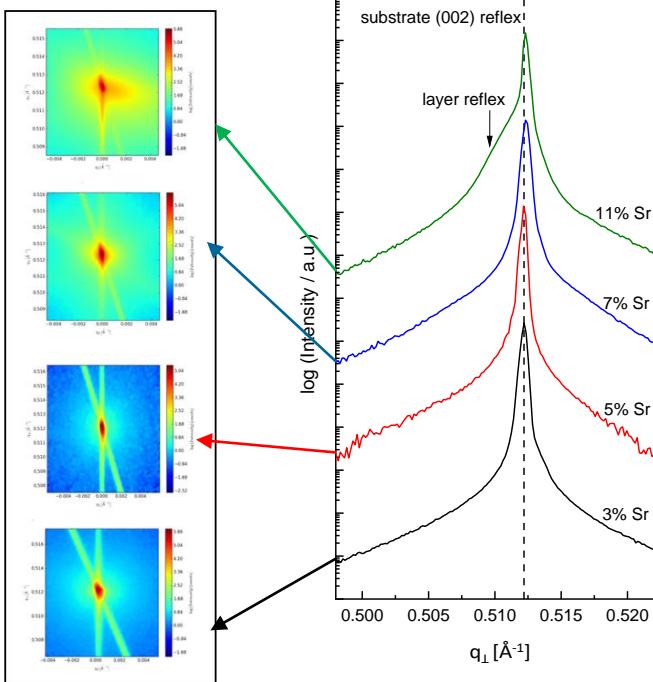
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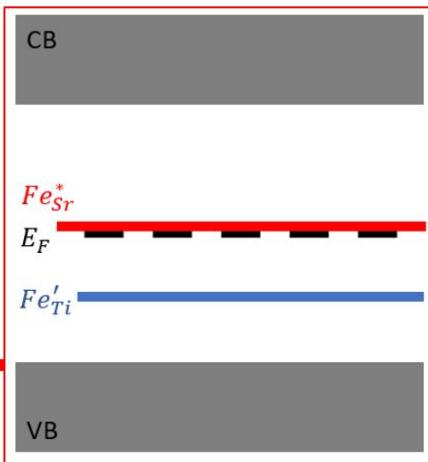
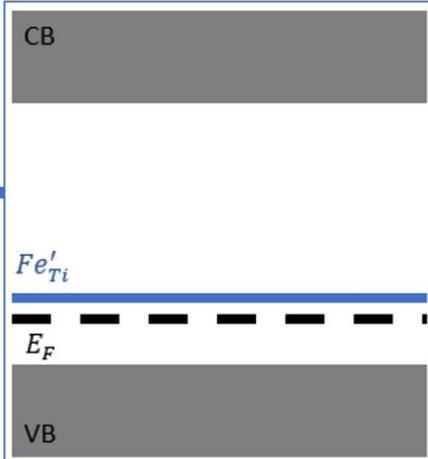
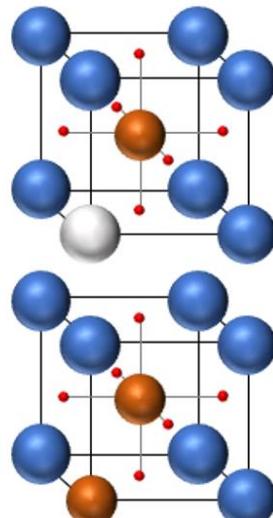
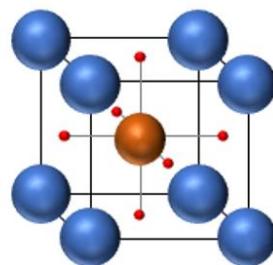
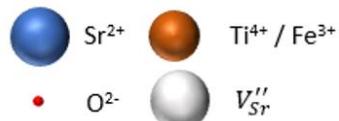
# Structure vs. Conductivity



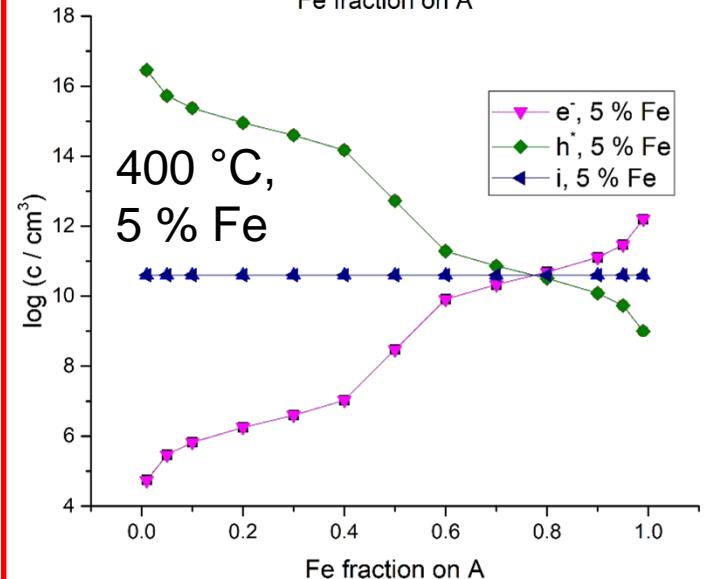
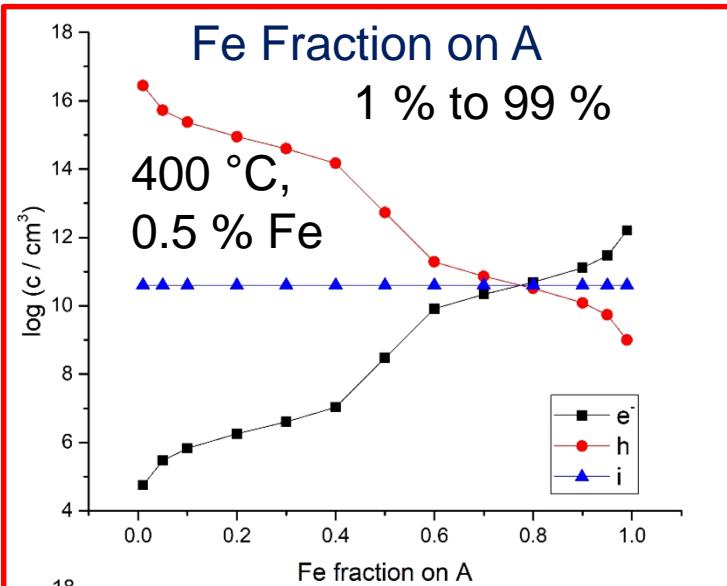
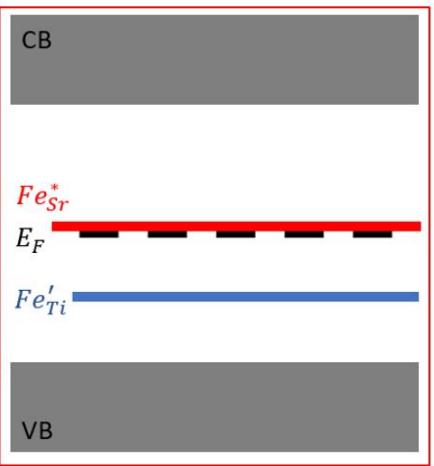
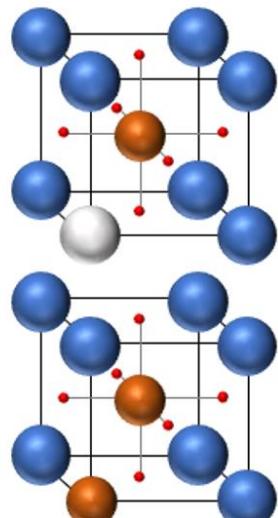
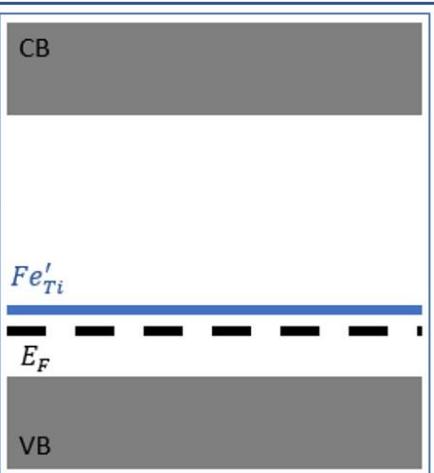
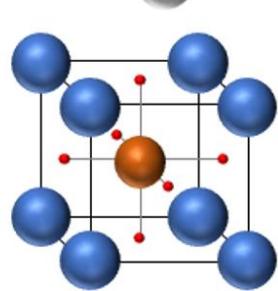
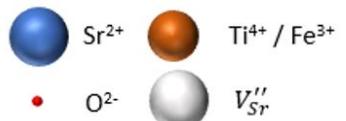
Structure and conductivity for thin films deposited from targets with a Sr overstoichiometry



# Model

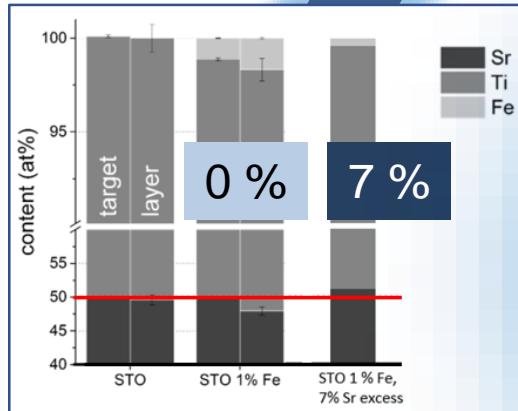


# Model

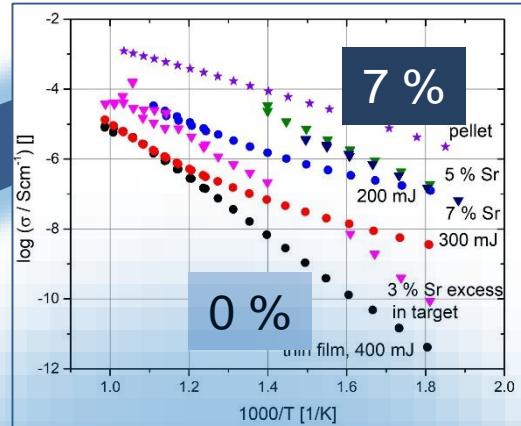


# Discussion

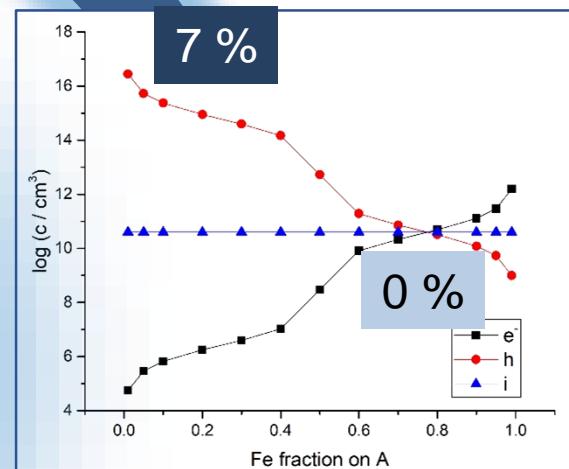
## 1. ICP-OES



5.  $\sigma$



## 4. Charge carrier concentration

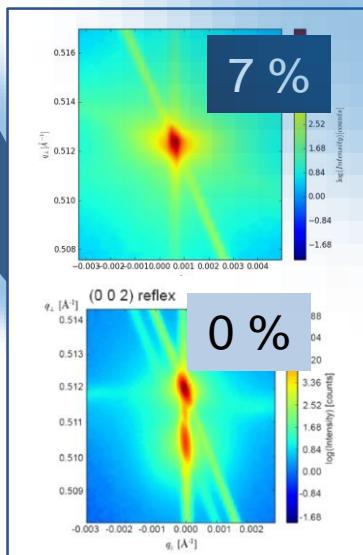


Fe:STO with Sr excess:

0 %

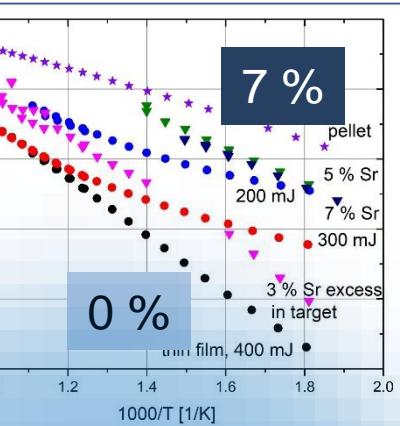
7 %

## 2. XRD

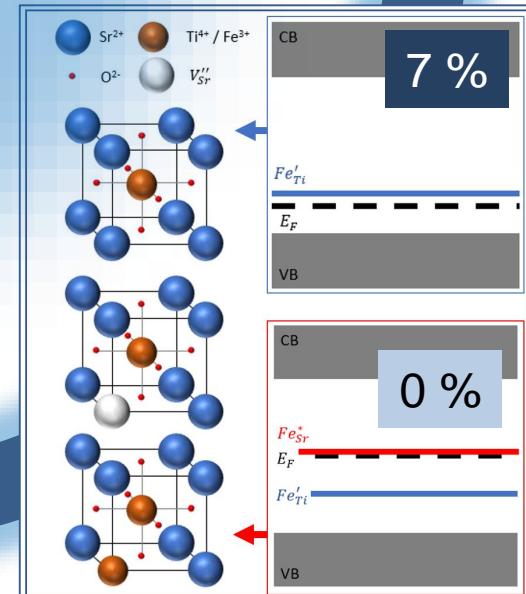


Structure

5.  $\sigma$



## 3. Band model



Thank you for your attention!



